



Docket No.: 4425-090

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TECHNOLOGY CENTER 2800

In re Application of

Pei-Ren JENG

U.S. Patent Application No. 09/729,833

Filed: December 6, 2000

For: METHOD FOR PATTERNING A DUAL DAMASCENE WITH RETROGRADE
IMPLANTATION

EXPEDITED PROCEDURE
: **RESPONSE UNDER 37 CFR 1.116**
:
:
: Confirmation No. 5660
: Group Art Unit: 2823
: Examiner: Hsien Lee

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Sir:

This paper is submitted in reply to the Office Action mailed *July 25, 2003*, which was made Final. Reconsideration and allowance of the subject application in view of the following remarks is respectfully requested.